

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Young Hoon PARK, et al.)
Serial No.: 10/511,883) Group Art Unit: 1763
Filed: October 19, 2004) Examiner:
For: APPARATUS AND METHOD FOR) NG, James Wai Heung
DEPOSITING THIN FILM ON WAFER)
USING REMOTE PLASMA)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This Amendment is submitted in response to the Office Action dated April 5, 2007.
Please amend the Application as follows: